

In re application of: Nadya G. Strelkova et al.

Serial No.: 10/800,219

Filed: March 12, 2004

Art Unit: 2825

For: Method and Apparatus for Verifying
The Post-Optical Proximity Corrected
Mask Wafer Image Sensitivity to
Reticle Manufacturing Errors



CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 2, 2006.

James R. Foley, Reg. No. 39,979

MAIL STOP: AMENDMENT
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Response to the Office Action mailed July 31, 2006.

The filing fee has been calculated as shown below:

	(Col. 1)		(Col. 2)	(Col. 3)
	Claims Remaining After Amendment		Highest No. Previously Paid for	Present Extra
TOTAL	* 18	MINUS	** 20	0
INDEP.	* 2	MINUS	** 3	0
<input type="checkbox"/> FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				

SMALL ENTITY

Rate	Addit. Fee
x 25 =	\$.00
x 100 =	\$.00
+ 180 =	\$.00
TOTAL	
ADDIT. FEE	\$.00

LARGE ENTITY

Rate	Addit. Fee
x 50 =	\$.00
x 200 =	\$.00
+ 360 =	\$.00
TOTAL	
	\$.00

OR

OR

- * If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3.
- ** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
- *** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.
- The "Highest Number Previously Paid For" (Total or independent) is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.

☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-2252. A duplicate copy of this sheet is enclosed.

☒ Any filing fees required under 37 CFR 1.16 for the presentation of extra claims.

☒ Any patent application processing fees under 37 CFR 1.17

Dated: October 2, 2006

James R. Foley Reg. No. 39,979
Attorneys of Record




PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/800,219)
)
Filed: March 12, 2004)
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Title: Method and Apparatus for Verifying)
the Post-Optical Proximity Corrected)
Mask Wafer Image Sensitivity to)
Reticle Manufacturing Errors)
)
Inventors: Nadya G. Strelkova et al.)
)
Art Unit: 2825)
)
Examiner: Nelson C. Lam)
)
Atty. Ref: 02-2396)

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James R. Foley, Reg. No. 39 979

RESPONSE TO THE OFFICE ACTION MAILED JULY 31, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application and in response to the Office Action mailed July 31, 2006, kindly enter the following amendments and consider the following remarks toward reconsideration of the present application.